Case 10623244

\$13371 250/\$.ccls. and 2005-01-(thermopile or radiant\$2 07 or infared) near 12:30:38 (sensor\$2 or detector\$2) and (thermopile or radiant\$2 or infared) near (sensor\$2 or detector\$2) and gas\$3 and (control\$3 or comput\$3 or analyz\$3) \$13370 73/\$.ccls. and 2005-(thermopile or radiant\$2 01-07 or infared) near 12:30:15 (sensor\$2 or detector\$2) and (thermopile or radiant\$2 or infared) near (sensor\$2 or detector\$2) and gas\$3 and (control\$3 or comput\$3 or analyz\$3) \$13369 438/\$.ccls. and (thermopile or radiant\$2 or infared) near (sensor\$2 or detector\$2) and (thermopile or radiant\$2 or infared) near (sensor\$2 or detector\$2) and gas\$3 and (control\$3 or comput\$3 or analyz\$3)

<u>\$13266</u>	semiconductor\$2 and interconnect\$3 and (via\$2 or hole\$2) and (first or second or tv interconnect\$3 and stress\$3 and void\$2
<u>S13265</u>	(siv or (stress near induc\$3 near void\$2)) and metal\$2 and buffer\$3 and interconnec
S13264	(siv or (stress near induc\$3 near void\$2)) and metal\$2 and buffer\$3

<u>\$13263</u>	<u>U</u>	USPT	(siv or (stress near induc\$3 near void\$2))
<u>S13262</u>	<u>U</u>	USPT	semiconductor\$2 and interconnect\$3 and (via\$2 or hole\$2)and siv\$3 and (buffer\$3 or insulat\$3 or seperat\$3) near (interconnect\$3 or metal or layer) and (siv or (stress near induc\$3 near void\$2))
<u>\$13261</u>	<u>U</u>	USPT	semiconductor\$2 and interconnect\$3 and (via\$2 or hole\$2)and siv\$3 and (buffer\$3 or insulat\$3 or seperat\$3) near (interconnect\$3 or metal or layer) and (siv\$1 or (stress near(induc\$3 or void\$2)))
<u>S13260</u>	<u>U</u>	USPT	semiconductor\$2 and interconnect\$3 and (via\$2 or hole\$2)and siv\$3 and (buffer\$3 or insulat\$3 or seperat\$3) near (interconnect\$3 or metal or layer) and (siv\$2 or (stress near(induc\$3 or void\$2))) and metal\$3
<u>S13259</u>	<u>U</u>	USPT	semiconductor\$2 and interconnect\$3 and (via\$2 or hole\$2)and siv\$3 and (buffer\$3 or insulat\$3 or seperat\$3) near (interconnect\$3 or metal or layer) and (siv\$2 or (stress near(induc\$3 or void\$2)))
<u>S13258</u>	<u>U</u>	USPT	semiconductor\$2 and interconnect\$3 and (via\$2 or hole\$2)and siv\$3 and (buffer\$3 or insulat\$3 or seperat\$3) near (interconnect\$3 or metal or layer)
<u>S13257</u>	<u>U</u>	USPT	semiconductor\$2 and interconnect\$3 and (via\$2 or hole\$2)and siv\$3 and (buffer\$3 or insulat\$3) near (interconnect\$3 or metal or layer)
<u>S13256</u>	<u>U</u>	USPT	semiconductor\$2 and interconnect\$3 and (via\$2 or hole\$2)and siv\$3 and buffer\$3
<u>S13255</u>	<u>U</u>	USPT	semiconductor\$2 and interconnect\$3 and (via\$2 or hole\$2)and siv\$3
<u>\$13254</u>	<u>U</u>	USPT	semiconductor\$2 and interconnect\$3 and (via\$2 or hole\$2) and (first or second or two) near interconnect\$3 and siv\$3 and buffer\$3
<u>S13253</u>	<u>U</u>	USPT	semiconductor\$2 and interconnect\$3 and (via\$2 or hole\$2) and (first or second or two) near interconnect\$3 and siv\$3
<u>S13252</u>	<u>U</u>	USPT	semiconductor\$2 and interconnect\$3 and (via\$2 or hole\$2) and (first or second or two) near interconnect\$3
<u>S13251</u>	<u>U</u>	USPT	semiconductor near process and (thermopile near (sensor\$2 or detector\$2) or infared\$2 near (sensor\$2 or detector\$2))
<u>S13250</u>	<u>U</u>	USPT	semiconductor near process
<u>\$13249</u>	<u>U</u>	USPT	('5967992' '5721430' '5650624' '5834777')!.PN. and semiconductor near process

<u>S13248</u>	<u>U</u>	USPT	(4935345 5047352 5589689 5650624 5721430 5834777 5967992 6348650 6469303)![pn] and semiconductor near process
<u>S13247</u>	<u>U</u>	USPT	(4935345 5047352 5589689 5650624 .5721430 5834777 5967992 6348650 6469303)![pn] and gas and semiconductor and (chamber\$2 or cell) and semiconductor near process
<u>S13246</u>	<u>U</u>	USPT	(4935345 5047352 5589689 5650624 5721430 5834777 5967992 6348650 6469303)![pn] and gas and semiconductor and (chamber\$2 or cell)
<u>\$13245</u>	<u>U</u>	USPT	('5967992' '5721430' '5650624' '5834777')!.PN. and gas and semiconductor and (chamber\$2 or cell)
<u>S13244</u>	<u>U</u>	USPT	(4935345 5047352 5589689 5650624 5721430 5834777 5967992 6348650 6469303)![pn]
<u>S13243</u>	<u>U</u>	USPT	(thermopile or radiant\$2 or infared) near (sensor\$2 or detector\$2) and gas and semiconductor near process
<u>S13242</u>	<u>U</u>	USPT	(thermopile or radiant\$2 or infared) near (sensor\$2 or detector\$2)
<u>S13241</u>	<u>U</u>	USPT	(thermopile or radiant\$2) near (sensor\$2 or detector\$2) and gas and semiconductor near process
<u>S13240</u>	<u>U</u>	USPT	(thermopile or radiant\$2) near (sensor\$2 or detector\$2) and gas and semiconductor near process and (chamber\$2 or cell)
<u>S13239</u>	<u>U</u>	USPT	(thermopile near (sensor\$2 or detector\$2) or infared\$2 near (sensor\$2 or detector\$2)) and gas and semiconductor and (chamber\$2 or cell)
<u>S13238</u>	<u>U</u>	USPT	(thermopile near (sensor\$2 or detector\$2) or infared\$2 near (sensor\$2 or detector\$2)) and gas and semiconductor near process and (chamber\$2 or cell)
<u>S13237</u>	<u>U</u>	USPT	(thermopile near (sensor\$2 or detector\$2) or infared\$2 near (sensor\$2 or detector\$2))
<u>S13236</u>	<u>U</u>	USPT	thermopile near (sensor\$2 or detector\$2) and gas and semiconductor and (chamber\$2 or cell)
<u>\$13235</u>	<u>U</u>	USPT	thermopile near (sensor\$2 or detector\$2) and gas and semiconductor near process

<u>S13234</u>	<u>U</u>	USPT	thermopile near (sensor\$2 or detector\$2) and gas and semiconductor near process and (chamber\$2 or cell)
<u>S13233</u>	<u>U</u>	USPT	thermopile near (sensor\$2 or detector\$2)
<u>S13232</u>	<u>U</u>	USPT	(thermopile or radiant\$2) near (sensor\$2 or detector\$2)
<u>S13231</u>	<u>U</u>	USPT	(6825543 6765279 6336269 6051862 6563162 6537437 6429596 4737469 4969028 and breakdown\$2 and (test\$3 or assess\$3 or find\$3 or ramp\$3)
<u>\$13230</u>	<u>U</u>	USPT	(6825543 6765279 6336269 6051862 6563162 6537437 6429596 4737469 4969028
<u>S13229</u>	<u>U</u>	USPT	contact\$2 near pad\$2 and electric\$3 near potential\$3 and conduct\$3 and dielectric\$ and insulat\$3 and ((contact\$2 near pad\$2) or pad\$2) and breakdown\$2 and (test\$3 or assess\$3 or find\$3) and leak\$4
<u>S13228</u>	<u>U</u>	USPT	contact\$2 near pad\$2 and electric\$3 near potential\$3 and conduct\$3 and dielectric\$ and insulat\$3 and ((contact\$2 near pad\$2) or pad\$2) and breakdown\$2 and (test\$3 or assess\$3 or find\$3)
<u>\$13227</u>	<u>U</u>	USPT	contact\$2 near pad\$2 and electric\$3 near potential\$3 and conduct\$3 and dielectric\$ and insulat\$3 and ((contact\$2 near pad\$2) or pad\$2)
<u>\$13226</u>	<u>U</u>	USPT	(5369045 5382536 5517224 5602576 5666142 5801431 5850242 6290334 6302504)![pn] and (inslulat\$4 or dielectric\$2) and trench\$3 and breakdown\$2 and (test\$3 or assess\$3 or find\$3)
<u>S13225</u>	<u>U</u>	USPT	(5369045 5382536 5517224 5602576 5666142 5801431 5850242 6290334 6302504)![pn]
<u>S13224</u>	<u>U</u>	USPT	6825543[uref]
<u>S13223</u>	<u>U</u>	USPT	((contact\$2 near pad\$2 and electric\$3 near potential\$3 and conduct\$3 and dielectric\$ and insulat\$3 and first near ((contact\$2 near pad\$2) or pad\$2))) and breakdown\$2 and (test\$3 or assess\$3 or find\$3)
<u>S13222</u>	<u>U</u>	USPT	('6825543')!.PN. and breakdown\$2 and leak\$4
<u>S13221</u>	<u>U</u>	USPT	((('6825543')!.PN. and (inslulat\$4 or dielectric\$2)) and trench\$3) and breakdown\$2 and 30

- S13220 USPT ((('6825543')!.PN. and (inslulat\$4 or dielectric\$2)) and trench\$3) and breakdown\$2 and (test\$3 or assess\$3 or find\$3)
- S13219 U USPT ((('6825543')!.PN. and (inslulat\$4 or dielectric\$2)) and trench\$3) and breakdown\$2 and failure\$2
- S13218 U USPT ((('6825543')!.PN. and (inslulat\$4 or dielectric\$2)) and trench\$3) and breakdown\$2
- <u>S13217</u> <u>U</u> USPT (('6825543')!.PN. and (inslulat\$4 or dielectric\$2)) and trench\$3
- <u>S13216</u> <u>U</u> USPT ('6825543')!.PN. and (inslulat\$4 or dielectric\$2)
- <u>S13215</u> <u>U</u> USPT 6825543 and 3 and pad\$4 and 30\$2 and plug\$3
- $\underline{S13214}$ \underline{U} USPT 6825543 and 3 and pad\$4 and 30\$2 and contact\$3 near plug\$3